

EXHIBIT 17

(12) **United States Patent**
Lyons et al.

(10) **Patent No.:** **US 6,566,214 B1**
(45) **Date of Patent:** **May 20, 2003**

(54) **METHOD OF MAKING A SEMICONDUCTOR DEVICE BY ANNEALING A METAL LAYER TO FORM METAL SILICIDE AND USING THE METAL SILICIDE AS A HARD MASK TO PATTERN A POLYSILICON LAYER**

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|-----------|----|---|---------|------------------|-----------|
| 5,134,085 | A | * | 7/1992 | Gilgen et al. | 437/52 |
| 5,160,407 | A | * | 11/1992 | Latchford et al. | 156/656 |
| 5,283,449 | A | * | 2/1994 | Ooka | 257/204 |
| 5,431,770 | A | * | 7/1995 | Lee et al. | 156/653.1 |
| 5,498,555 | A | * | 3/1996 | Lin | 437/35 |
| 5,605,854 | A | * | 2/1997 | Yoo | 437/44 |
| 5,955,761 | A | * | 9/1999 | Yoshitomi et al. | 257/336 |
| 6,046,098 | A | * | 4/2000 | Iyer | 438/622 |
| 6,069,044 | A | * | 5/2000 | Wu | 438/299 |
| 6,127,249 | A | * | 10/2000 | Hu | 438/583 |
| 6,159,856 | A | * | 12/2000 | Nagano | 438/683 |
| 6,204,105 | B1 | * | 3/2001 | Jung | 438/238 |

(73) Assignee: **Advanced Micro Devices, Inc.**, Sunnyvale, CA (US)

(*) Notice: Subject to any disclaimer, the term of this patent is extended or adjusted under 35 U.S.C. 154(b) by 0 days.

OTHER PUBLICATIONS

Stanley Rolf: "Silicon Processing for the VLSI Era, vol. 2: Process Integration," 1990, pp. 144-152, Lattice Press, Sunset Beach, California.

(21) Appl. No.: **10/047,036**

(22) Filed: **Jan. 17, 2002**

(51) **Int. Cl.**⁷ **H01L 21/3213**; H01L 21/336

(52) **U.S. Cl.** **438/305**; 438/592; 438/655; 438/682; 438/683

(58) **Field of Search** 438/301, 303, 438/306, 586, 592, 595, 648, 649, 655, 682, 683, 305

* cited by examiner

Primary Examiner—Carl Whitehead, Jr.
Assistant Examiner—Stephen W. Smoot

(74) *Attorney, Agent, or Firm*—Foley & Lardner

(56) **References Cited**

U.S. PATENT DOCUMENTS

4,460,435 A * 7/1984 Maa 156/643
4,818,715 A * 4/1989 Chao 437/44

(57) **ABSTRACT**

A method of making a semiconductor device is provided. A polysilicon layer is formed over a substrate and a metal layer is formed on the polysilicon layer. The metal layer and the polysilicon layer are annealed to form a metal silicide layer on the polysilicon layer. The metal silicide layer is patterned and the polysilicon layer is then patterned using the patterned metal silicide layer as a mask. The patterned metal silicide and polysilicon layers may be used as a gate electrode of a MOSFET.

28 Claims, 5 Drawing Sheets

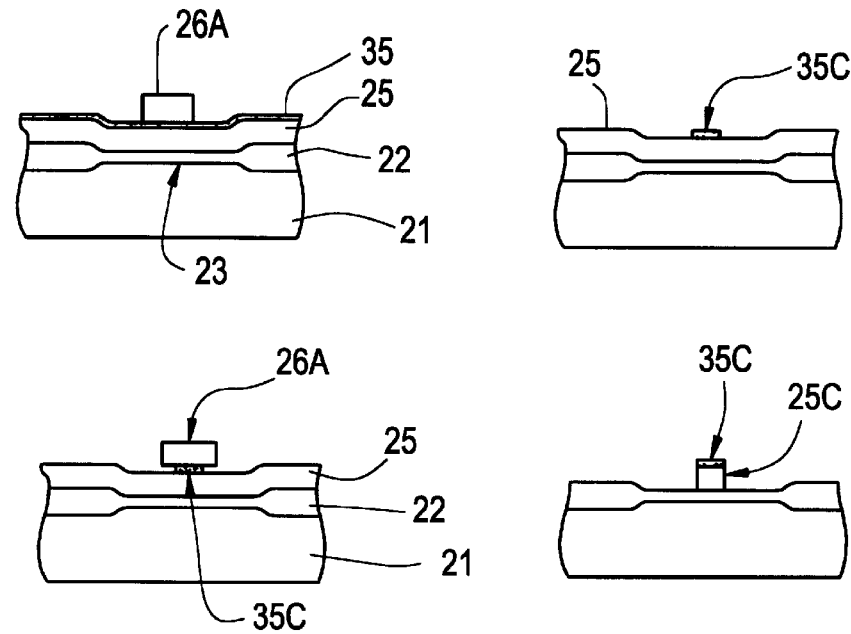


FIG. 1A
PRIOR ART

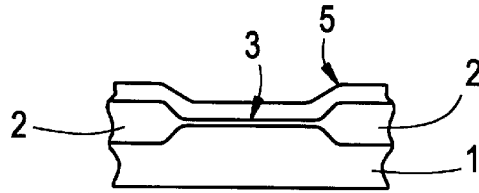


FIG. 1B
PRIOR ART

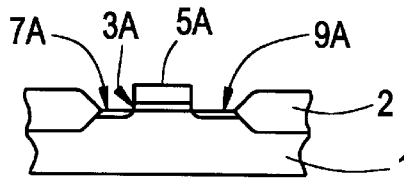


FIG. 1C
PRIOR ART

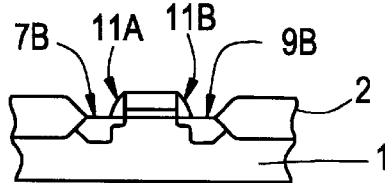


FIG. 1D
PRIOR ART

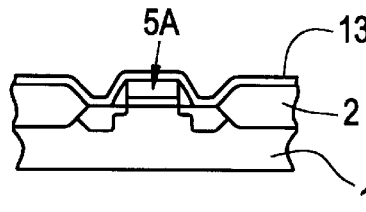


FIG. 1E
PRIOR ART

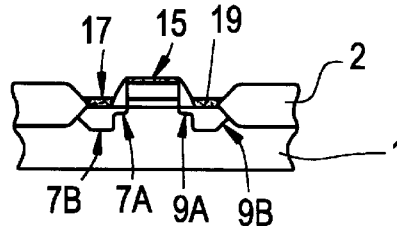


FIG. 2A

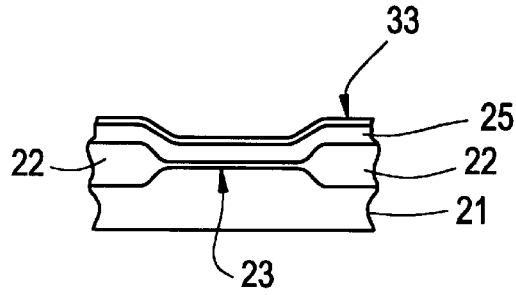


FIG. 2B

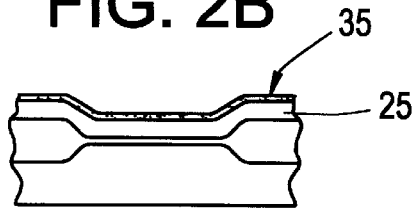


FIG. 2C

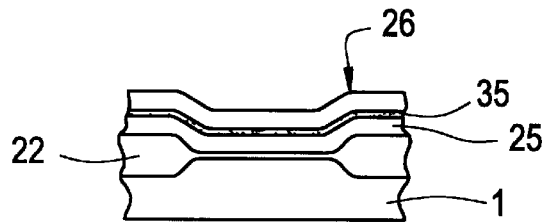


FIG. 2D

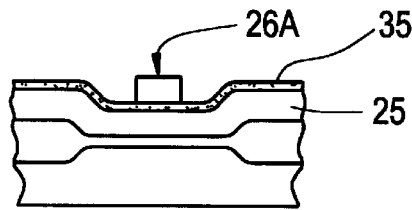


FIG. 2E

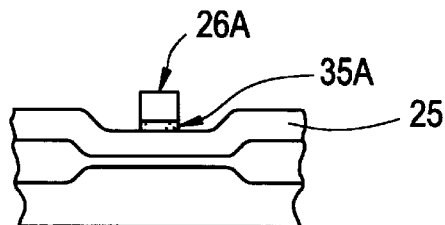


FIG. 2F

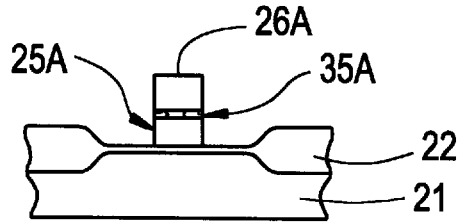


FIG. 2G

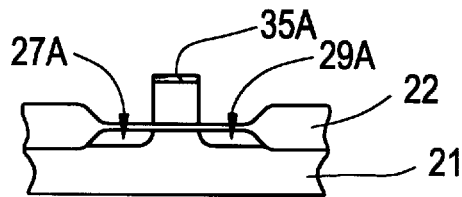


FIG. 2H

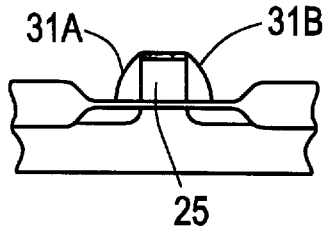


FIG. 2I

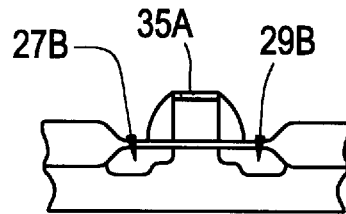
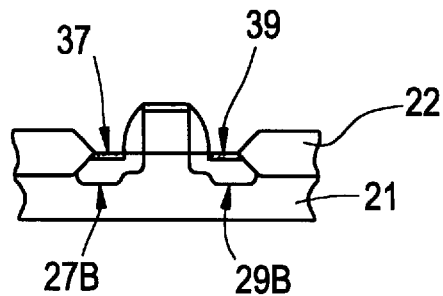


FIG. 2J



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